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21. (New) The device of claim 1, wherein said metal plug contact contacts said field oxide layer.

~~22. (New) The method of claim 5, wherein said metal plug contact contacts said field oxide layer.~~

23. (New) The device of claim 9, wherein said metal plug contact contacts said field oxide layer.

24. (New) The method of claim 13, wherein said metal plug contact contacts said field oxide layer.

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